



IFW

**PATENT**

**THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of:  
Yi-Ming Sheu

Confirmation Number: 6852

Serial No.: 10/619,114

Group Art Unit: 2823  
Examiner: Brewster, William

Filed: 07/14/2003

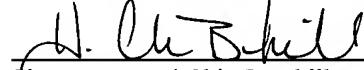
TKHR Docket No. 252016-1300

Top-Team Ref. 0503-9540US

For: NARROW WIDTH EFFECT IMPROVEMENT WITH PHOTORESIST PLUG PROCESS  
AND STI CORNER ION IMPLANTATION

**Certificate of Mailing**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop Amendment; Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on November 22, 2004.

  
\_\_\_\_\_  
Signature – Hui Chin Barnhill

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Mail Stop – Amendment  
Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Notice of Non-Compliant Amendment mailed November 10, 2004, this amendment is submitted. This amendment is identical to the previously-filed amendment, except that it includes in the listing of claims “1-25. (Canceled).”

The Office Action mailed July 23, 2004 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.